

## Publikationen

(2011): Use of ELID-grinding on brittle-hard materials. In: International Journal of Mechatronics and Manufacturing Systems, vol. 4, no. 6, pp. 553-568. DOI: 10.1504/IJMMS.2011.044105.

(2010): ELID supported grinding of thin sapphire wafers. In: Proceedings of SPIE: 5th International Symposium on Advanced Optical Manufacturing and Testing Technologies: Advanced Optical Manufacturing Technologies, Volume 7655.

(2010): ELID supported grinding of thin Sapphire wafers. In: 5th SPIE International Symposium on Advanced Optical Manufacturing and Testing Technologies, Dalian, China.